



520.41003X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Y. KIMURA, et al.  
Application No.: 10/019,407  
Filed: March 25, 2002  
For: POLYCRYSTALLINE SEMICONDUCTOR THIN FILM  
SUBSTRATE MANUFACTURING METHOD OF THE SAME,  
SEMICONDUCTOR DEVICE AND ELECTRONIC DEVICE  
Art Unit: 2813  
Examiner: L. M. Schillinger

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

February 1, 2005

Sir:

In response to the Office Action dated October 1, 2004, the period of response for which extension is requested by the attached Petition for Extension of Time, please amend the above-identified application as listed below and as set forth on the following pages:

**Amendments to the Claims and**

**Remarks are included following the amendments.**